 arch	 -

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/014,640	KUPFER, MICHAEL D.	
Examiner	Art Unit	
Jung W. Kim	2132	

SEARCHED				
Class	Subclass	Date	Examiner	
726	3,27	9/19/2005	JK	
		.,		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
		*		

SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
searched east (us-pgpub uspat usocr epo jpo derwent ibm_tdb); acm online and google scholar	9/19/2005	JK
inventor name search on palm; no dobule patenting issues	9/19/2005	JK
707/1 with text search	9/19/2005	JK
see enclosed search history		
·		